

Subst. Form PTO-1449 JUN 20 2003		Atty. Docket No.: FLCZ 2 00364 (H-4136)		Serial No.: 10/082,151	
APPLICANT'S(S) INFORMATION DISCLOSURE STATEMENT		Applicant(s): Szymanski, et al.		RECEIVED JUN 24 2003 TCL 100	
		Filing Date: February 25, 2002			

U.S. PATENT DOCUMENTS							
Initial*		Document No.	Date	Name	Class	Subcl.	Filing Date
EV	AA	5,929,259	07/1999	Lockemeyer	—	—	
AV	AB	5,057,481	10/1991	Bhasin	—	—	
AV	AC	5,384,302	01/1995	Gerdes, et al.	—	—	
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						

FOREIGN PATENT DOCUMENTS							
		Document No.	Date	Country	Class	Subcl.	Translation
AV	AP	EP 0 327 356	02/1989	Europe	—	—	
AV	AQ	EP 0 496 386	01/1992	Europe	—	—	
AV	AR	WO 97/46317	06/1997	PCT	—	—	
	AS						
	AT						
	AU						

OTHER ART		
	AV 1	
	AV 2	

Examiner: <i>mmmmmm</i>	Date Considered: 11/17/03
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* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if in conformance and not considered. Include copy of this form with next communication to applicant.

FORM 6-1

Section 2. Form PTO - 1449 (Modified)

FORM PTO-1449
INFORMATION DISCLOSURE
STATEMENT BY APPLICANT

ATTY. DOCKET NO.
H-4136

SERIAL NO.
10/082,761



APPLICANT Szymanski et al

FILING DATE
February 25, 2002

GROUP

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	PATENT NUMBER	ISSUE DATE	PATENTEE	CLASS	SUBCLASS	FILING DATE If appropriate
lu	2,069,060	Jan. 1937	Fessler	—	—	
as	4,812,437	Mar. 1989	Nojiri et al	—	—	
us	4,822,900	Apr. 1989	Hayden	—	—	
as	4,939,114	Jul. 1990	Nojiri et al	—	—	
as	5,100,859	Mar. 1992	Gerdes et al	—	—	
as	5,145,824	Sep. 1992	Buffum et al	—	—	
as	5,187,140	Feb. 1993	Thorsteinson et al	—	—	

FOREIGN PATENT OR PUBLISHED FOREIGN PATENT APPLICATION

	DOCUMENT NUMBER	PUBLICATION DATE	COUNTRY OR PATENT OFFICE	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
lu	EP 003642	Aug. 1979	EPO	—	—		
as	EP 076504	Apr. 1983	EPO	—	—		
us	EP 266015	May 1988	EPO	—	—		
as	EP 927575	Jul. 1999	EPO	—	—		
as	WO 00/15333	Mar. 2000	WO	—	—		
as	WO 00/15334	Mar. 2000	WO	—	—		
as	WO 00/15335	Mar. 2000	WO	—	—		
as	JP 11240777	Sep. 1999	JP	—	—	abstract only	
as	JP 2000044331	Feb. 2000	JP	—	—	x	

OTHER DOCUMENTS (Including Author, Title, Date, Relevant Pages, Place of Publication*)

us	Encycl. of Chemical Technology (Kirk-Othmer) Vol. 5, pp 610-633; Vol. 9, pp 445-471.	update
us	Treatise on Materials Science and Technology Edited by Franklin Wang; Vol. 9, pp 79-81.	update
us	Introduction to the Principles of Ceramic Processing, (Reed) pp 152-182. © 1988	now with
EXAMINER	DATE CONSIDERED	1/17/05

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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U.S. PATENT DOCUMENTS

EXAMINER INITIAL	PATENT NUMBER	ISSUE DATE	PATENTEE	CLASS	SUBCLASS	FILING DATE If appropriate
EV	5,380,697	Jan. 1995	Matusz et al			
EV	5,384,302	Jan. 1995	Gerdas et al			
EV	5,395,812	Mar. 1995	Nagase et al			
EV	5,512,530	Apr. 1996	Gerdas et al			
EV	5,733,842	Mar. 1998	Gerdas et al			
EV	5,739,075	Apr. 1998	Matusz			
EV	6,103,916	Aug. 2000	Takada et al			
EV	6,114,553	Sep. 2000	Kiriki et al			

FOREIGN PATENT OR PUBLISHED FOREIGN PATENT APPLICATION

		DOCUMENT NUMBER	PUBLICATION DATE	COUNTRY OR PATENT OFFICE	CLASS	SUBCLASS	TRANSLATION	
							YES	NO

OTHER DOCUMENTS (Including Author, Title, Date**, Relevant Pages, Place of Publication***)

EXAMINER mm mm DATE CONSIDERED 11/17/03

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.